Notice of References Cited Application/Control No. 10/564,294 Examiner Leah S. Lovell Applicant(s)/Patent Under Reexamination DE VAAN, ADRIANUS JOHANNE Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-7,073,933	07-2006	Gotoh et al.	362/624
*	В	US-6,547,400	04-2003	Yokoyama, Osamu	353/98
*	С	US-6,601,962	08-2003	Ehara et al.	362/612
*	D	US-4,975,808	12-1990	Bond et al.	362/609
*	Ε	US-5,769,521	06-1998	Osawa et al.	362/27
*	F	US-6,065,845	05-2000	Miyazaki, Kiyomi	362/26
*	G	US-6,139,163	10-2000	Satoh et al.	362/612
*	н	US-6,508,571	01-2003	Chuang, Fu-Ming	362/237
*	1	US-6,840,647	01-2005	Hayashi et al.	362/84
	7	US-			
	K	US-			
	L	US			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν					
	0					
	Р					
	Q					
	R					
	S					
	Т					

NON-PATENT DOCUMENTS

	NON-FATENT DOCUMENTS					
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U					
	v					
	w					
	х					

A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.